

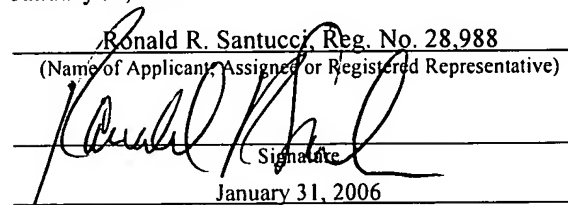
2834
IFU

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Tetsuo YAMADA, et al.
Serial No. : 10/518,704
For : THIN FILM PIEZOELECTRIC RESONATOR, THIN
FILM PIEZOELECTRIC DEVICE, AND
MANUFACTURING METHOD THEREOF (As Amended)
Filing Date : December 17, 2004
Examiner : Not Yet Assigned
Group Art Unit : 2834
Confirmation No. : 5674

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I hereby certify that this correspondence is being deposited with
the United States Postal Service as first class mail in an envelope
addressed to: Mail Stop Amendment, Commissioner for
Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on
January 31, 2006.

Ronald R. Santucci, Reg. No. 28,988
(Name of Applicant, Assignee or Registered Representative)

January 31, 2006
Date of Signature

THIRD PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Preliminary to the examination of the above-referenced patent application,

Applicants respectfully request that the application be further amended as follows.

Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this paper.

Remarks begin on page 13 of this paper.